



1201.68291

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Eden et al.
Serial No.: 10/829,666
Patent No. 7,372,202
Conf. No.: 7738
Filed: 04/22/2004
Issued: 05/13/2008
For: PHASE LOCKED
MICRODISCHARGE ARRAY
AND AC, RF OR PULSE
EXCITED MICRODISCHARGE
Art Unit: 2879
Examiner: Macchiarolo, Peter J.

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Attn: Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

August 6, 2008

Date

Registration No. 43,874

Attorney for Applicant(s)

REQUEST FOR CERTIFICATE OF CORRECTION UNDER RULE 322

Attn: Certificate of Corrections Branch
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certificate
AUG 12 2008
of Correction

Dear Sir:

In accordance with 37 C.F.R. 1.322, patentee, through its attorneys, respectfully requests that a Certificate of Correction be issued in the above-referenced patent.

The errors occurred as a result of mistakes on the part of the Patent and Trademark Office and the changes include the following:

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In the Section References Cited, OTHER PUBLICATIONS (Continued):

Page 2, delete "1143-1147" and insert -- 1142-47 -- therefor.

(Office Action, 7/21/06, Notice of References Cited)

In The Issued Patent:

Column 2, line 17, after "BRIEF DESCRIPTION OF THE DRAWINGS," please insert the following paragraph.

-- The patent or application file contains one drawing executed in color. Copies of this patent or patent application publication with color drawing(s) will be provided by the Office upon request and payment of the necessary fee. --

(Amendment Pursuant to 37 C.F.R. § 1.312 dated 10/09/07)

Column 3, replace lines 20-35 with the following paragraph.

-- More generally, a phase-locked microdischarge array of the invention is an important new device that can form a substitute for compact semiconductor lasers or other optical sources in many applications, such as illumination for microscopy. Preferred embodiment arrays of the invention act as a single source that is capable of producing a tightly focused beam, the energy of microdischarges in the array combining to produce a significantly more powerful beam than is available from a single microdischarge device. An array of the invention is also highly compact. For example, a substrate of the invention might be less than one mm thick and have a diameter of only a few millimeters, for example <3mm. Preferred Fresnel array embodiments of the invention effectively produce a combined light source and lens. --

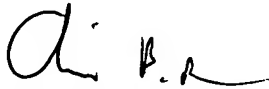
(Specification, page 5, lines 4-14)

REMARKS

A Certificate of Correction incorporating the delineated changes is enclosed in duplicate herewith. Since the mistakes were on the part of the Patent and Trademark Office, a Certificate of Correction should be issued without expense to the patentee and such is respectfully requested.

Respectfully submitted,

GREER, BURNS & CRAIN, LTD.

By 
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Registration No. 43,874

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August 6, 2008

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UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

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APPLICATION NO.: 10/829,666
ISSUE DATE : 05/13/2008
INVENTOR(S) : Eden et al.

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MAILING ADDRESS OF SENDER (Please do not use customer number below):

Steven P. Fallon
Greer, Burns & Crain, Ltd.
300 S. Wacker Drive, Suite 2500
Chicago, IL 60606

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